

Form PTO 1449
(Modified)U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICE

ATTY DOCKET NO.

251811US2

SERIAL NO.

10/822,816

LIST OF REFERENCES CITED BY APPLICANT

APPLICANT

Takeshi NANJYO, et al.

FILING DATE

April 13, 2004

GROUP

288+

AU 2873

U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
47	AA	6,467,881	10/22/02	KATOH			
	AB	6,485,126	11/26/02	KATO et al.			
	AC	6,367,914	04/09/02	OHTAKA et al.			
	AD	6,312,108	11/06/01	KATO			
	AE	6,332,669	12/25/01	KATO et al.			
	AF	6,450,618	09/17/02	KATO et al.			
	AG	6,150,698	11/21/00	OHTSUKA et al.			
	AH	5,633,523	05/27/97	KATO			
	AI	5,811,353	09/22/98	NANJO			
	AJ	5,668,413	09/16/97	NANJO			
	AK	5,304,357	04/19/94	SATO et al.			
	AL	5,108,843	04/28/92	OHTAKA et al.			
	AM	5,017,987	05/21/91	NANJOH et al.			
47	AN	5,448,113	09/05/95	SUZUKI et al.			

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION	
					YES	NO
	AO					
	AP					
	AQ					
	AR					
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OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, etc.)

	AW		
	AX		
	AY		
	AZ		

☐ Additional References sheet(s) attached

Examiner

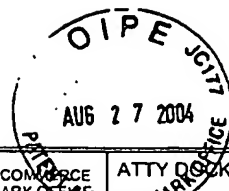
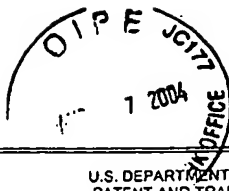
LOHA BEN

Date Considered

1/2/06

*Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE	
AA	5,408,113	04/18/95	KANNO et al.				
AB	6,324,149	11/27/01	MIFUNE et al.				
AC	6,636,368	10/21/03	OHTAKA				
AD	6,710,949	03/23/04	OHTAKA				
AE							
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AZ						<input type="checkbox"/> Additional References sheet(s) attached	
Examiner LOHA BEN				Date Considered 1/2/06			
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	AG						
	AH						
	AI						
	AJ						
	AK						
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION YES NO		
LM	AL	2941952	06/18/1999	JAPAN (with WO 96/41224)			X
	AM	WO 96/41224	12/19/1996	WIPO			
	AN	3016871	12/24/1999	JAPAN (with corr. WO 96/41226)			X
	AO	WO 96/41226	12/19/1996	WIPO			
	AP	6-138403	05/20/1994	JAPAN (with English Abstract)			X
	AQ	2000-2842	01/07/2000	JAPAN (with English Abstract)			X
	AR	2002-131838	05/09/2002	JAPAN (with English Abstract)			X
	AS	5-2973	01/08/1993	JAPAN (with English Abstract)			X
LM	AT	8-84485	03/26/1996	JAPAN (with English Abstract)			X
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LM	AU	K. E. PETERSEN, Applied Physics Letters, vol. 31, no. 8, pages 521-523, "MICROMECHANICAL LIGHT MODULATOR ARRAY FABRICATED ON SILICON", October 15, 1977					
	AV	O. SOLGAARD, et al., Optics Letters, vol. 17, no. 9, pages 688-690, "DEFORMABLE GRATING OPTICAL MODULATOR", May 1, 1992					
	AW	L. J. HORNBECK, SPIE Critical Reviews Series, vol. 1150, pages 86-102, "DEFORMABLE-MIRROR SPATIAL LIGHT MODULATORS", 1989					
	AX	P. F. VAN KESSEL, et al., Proceedings of the IEEE, vol. 86, no. 8, pages 1687-1704, "A MEMS-BASED PROJECTION DISPLAY", August 1998					
	AY	D. S. DEWALD, Optical Engineering, vol. 39, no. 7, pages 1802-1807, "USING ZEMAX IMAGE ANALYSIS AND USER-DEFINED SURFACES FOR PROJECTION LENS DESIGN AND EVALUATION FOR DIGITAL LIGHT PROCESSING™ PROJECTION SYSTEMS", July 2000					
LM	AZ	O. BUTSURI, vol. 68, no. 3, pages 285-289, "DIGITAL MICRO-MIRROR DEVICE", 1999 (introduces the concepts of reference AX)				<input type="checkbox"/> Additional References sheet(s) attached	
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